



Attorney Docket No. 0138-000

#6/Election
Opted
8/8/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Doak et al.
Serial No.: 09/887,777 : Group Art Unit: 2822
Filed: June 22, 2001 : Examiner: Ken Pierre
Title: Method and Apparatus for Preparing Nitride Semiconductor Surfaces

RESPONSE TO RESTRICTION REQUIREMENT

Responsive to the Election/Restriction Requirement dated July 1, 2002, applicant elects Group II, Claims 12 - 18 and 36-38 drawn to Semiconductor device fabrication, classified in class 257, subclass 760. The Commissioner is authorized to charge any fee required by this paper to Deposit Account No. 07-0135.

Respectfully submitted,

By

Thomas D. MacBlain
Attorneys for Applicant
Registration No. 24,583

Dated: 8/11/02

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08-05-02

Attorney Docket No. 9138-0060

2822

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Doak et al.

Serial No: 09/887,777

Filed: June 22, 2001

For: Method and Apparatus for Preparing Nitride Semiconductor Surfaces

CERTIFICATE OF MAILING BY EXPRESS MAIL
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Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

I hereby certify that this correspondence, consisting of this Certificate of Mailing by Express Mail, Response to Restriction Requirement and a return-receipt postcard are being deposited in the United States Postal Service as Express Mail in an envelope addressed to:

Commissioner for Patents
Washington, D.C. 20231

on

8/1/02
Date

Suzanne Shields
Suzanne Shields

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